



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re patent application of

Docket No.: 00750455AA

Basanth Jagannathan, *et al.*

Serial No.: 09/843,783

Group Art Unit: 2823

Filed: April 30, 2001

Examiner: William D. COLEMAN

For: **METHOD TO INCREASE CARBON AND BORON DOPING
CONCENTRATION IN Si AND SiGe FILMS**

Mail Stop: Non-final amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

As a supplement to the response filed on November 18, 2003, Applicants submit the following Remarks.

Applicants believe that no extensions of time or fees for net addition of claims are required at this time. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No.09-0458.